

Fig.1a  
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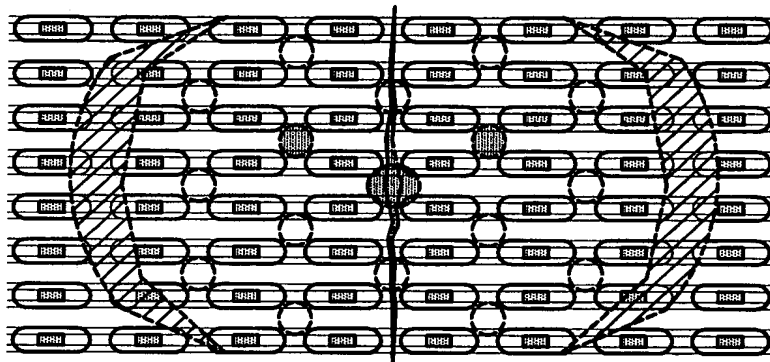


Fig.1b  
<Prior Art>

Dong Su PARK et al.

"A Method for Forming Capacitor of Semiconductor Device"

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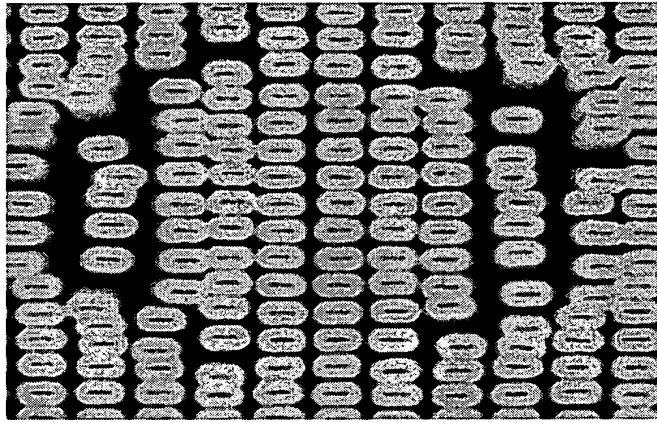


Fig.2  
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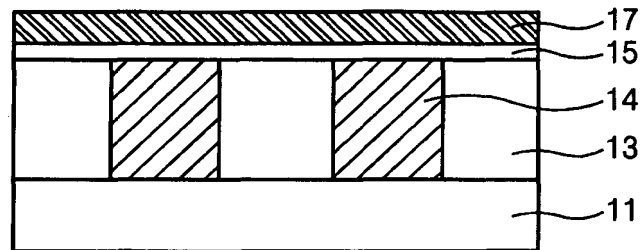


Fig.3a

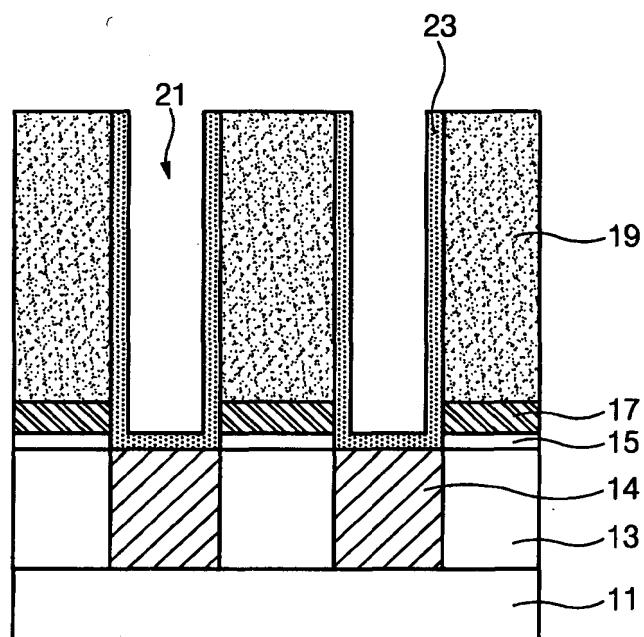


Fig.3b

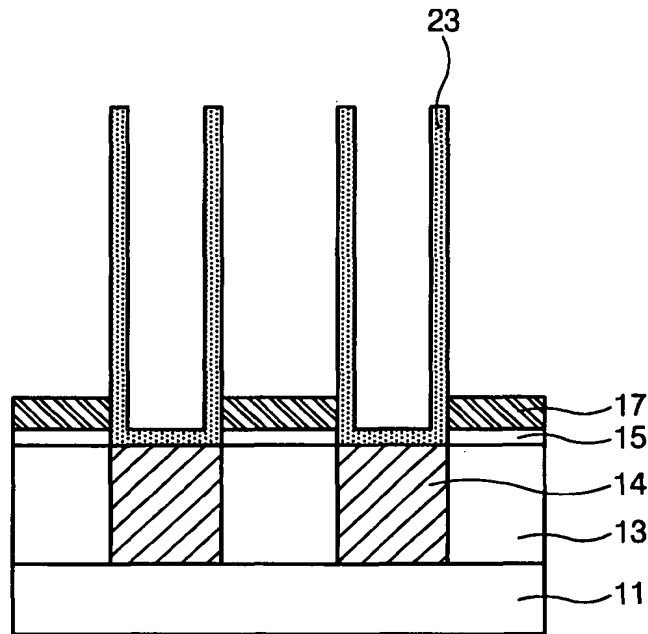


Fig.3c

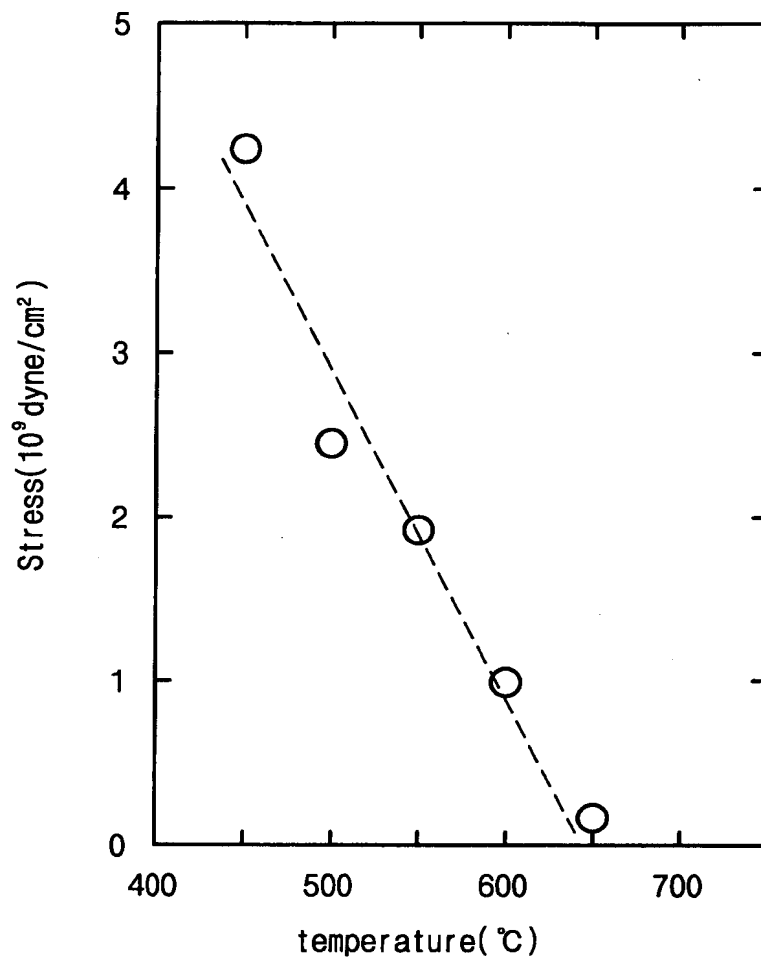


Fig.4